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PATENT APPLICATION

*FILE
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
	:	Examiner: J. S. Ruggles
YASUHISA INAO, et al.)	
	:	Group Art Unit: 1756
Application No.: 10/663,691)	
	:	
Filed: September 17, 2003)	
	:	
For: MASK, EXPOSURE)	
APPARATUS, AND	:	
EXPOSURE METHOD)	August 29, 2006

Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

PETITION FOR EXTENSION OF TIME
UNDER 37 C.F.R. § 1.136(a)

Sir:

Applicants petition the Commissioner for Patents to extend the time for response to the Office Action dated May 8, 2006 for one month from August 8, 2006 to September 8, 2006.

Submitted herewith is a check for \$120.00 to cover the fee for the extension under 37 C.F.R. § 1.17. Any deficiency in or overpayment of this fee should be charged or credited to Deposit Account No. 06-1205. A duplicate copy of this petition is enclosed.

08/31/2006 JADD01 00000073 10663691

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Applicants' undersigned attorney may be reached in our Costa Mesa,
California office at (714) 540-8700. All correspondence should continue to be directed to
our below-listed address.

Respectfully submitted,

A handwritten signature in black ink, appearing to read "Damond E. Vadnais", is written over a horizontal line.

Damond E. Vadnais
Attorney for Applicants
Registration No. 52,310

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